



**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Application No.: 09/977,158  
Filing Date: October 11, 2001  
Applicant: Lai et al.  
Group Art Unit: 1763  
Examiner: Sylvia R. MacArthur  
Title: Wafer Thinning Techniques  
Attorney Docket: 4675-000373

Director of The United States Patent and Trademark Office  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

*OK'd to enter  
Jan 21/6/04*

**AMENDMENT**

Sir:

In response to the Office Action mailed January 8, 2004, please amend the application as follows and consider the remarks set forth below.

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks** begin on page 2 of this paper.